



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Cui et al. Application No: 10/824,313 Confirmation No: 5975 Filed: April 13, 2004 Title: ELECTRON BEAM TREATMENT OF Si _x N _y FILMS	Group Art Unit: 2823 Examiner: Khiem D. Nguyen Attorney Docket No: 007034 USA P03/DSM/BCVD/JW February 23 rd , 2005 San Francisco, California
-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------	---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner Nguyen:

This communication is in response to the Office Action mailed on
November 23, 2004, and is being filed within three months thereof.

Certificate of Transmission

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office at (703) 872-9306 on the date shown below.

By: _____

Ashok Janah

Date: February 23, 2005